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Attorney Docket No.: NECV 16.966

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Kazuyoshi UENO
Serial No.: 09/490,705
Filed: January 24, 2000
Title: **SEMICONDUCTOR DEVICE AND A METHOD FOR FORMING A VIA HOLE IN A SEMICONDUCTOR DEVICE**
Examiner: T. Tran
Group Art Unit: 2811

U. S. Patent & Trademark Office
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AMENDMENT

SIR:

Responsive to the Office Action dated August 1, 2001, the time for responding thereto expiring after November 1, 2001, the period for responding not being extended for more than one month, please amend the subject application as follows: